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PATENT

#61a

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s)	Janssens, et al.	Examiner:	Unassigned
Serial No.:	Unassigned	Group Art Unit:	Unassigned
Confirmation No.:	Unassigned	Docket:	294-114 PCT/US
Filed:	Herewith	Dated:	December 12, 2001
For:	METHOD AND APPARATUS FOR DETERMINING A FLOW PATTERN OF A FLUID IN A SPACE		

Commissioner for Patents  
Washington, DC 20231

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on December 12, 2001*

Signature: \_\_\_\_\_

**PRELIMINARY AMENDMENT**

Sir:

In order to place the application in proper form for examination, Applicants hereby  
amend the specification as follows:

**IN THE SPECIFICATION:**

On page 1, before line 1, after the title, please insert the following:

21  
This application is the U.S. National Phase of International Application Number  
PCT/IB00/00865 filed on June 28, 2000, which is incorporated herein by reference.

**BACKGROUND OF THE INVENTION**

The invention relates to a method for determining a low pattern of a fluid in a space.